

In the Claims:

1. (Original) A semiconductor wafer having an asymmetric edge profile (EP) extending between an inner edge profile (EP_{in}) and an outer edge profile (EP_{out}) as illustrated by FIG. 1, which is incorporated herein;

5 wherein t is a thickness of the semiconductor wafer, ϕ_1 is an angle in a range between about 30° and about 85° , R is a radius of an arc that defines EP_{in} at a point of intersection with a top surface of the semiconductor wafer, and α is an acute angle that represents an angle of intersection between a bottom surface of the semiconductor wafer and a line that is tangent to the arc at a point on EP_{out} ; and
10 wherein:

$$\begin{aligned}A_1 &= R(1 - \cos\phi_1); \\A_2 &= R(1 - \sin\alpha) + (t - R\sin\phi_1 - R\cos\alpha)\cot\alpha; \\B_1 &= R\sin\phi_1; \text{ and} \\B_2 &= t - R\sin\phi_1.\end{aligned}$$

2. (Original) The wafer of Claim 1, wherein R is in a range between about $0.23t$ and about $0.5t$.

3. (Original) The wafer of Claim 2, wherein A_2 is greater than about two times A_1 .

4. (Original) The wafer of Claim 2, wherein ϕ_1 is in a range between about 60° and about 75° .

5. (Original) The wafer of Claim 2, wherein t is in a range between about $625\text{ }\mu\text{m}$ and about $825\text{ }\mu\text{m}$.

6. (Currently amended) A semiconductor wafer having an asymmetric edge profile (EP) extending between an inner edge profile (EP_{in}) and an outer edge profile (EP_{out}) as illustrated by FIG. 1, which is incorporated herein; wherein ϕ_1 is an angle in a range between about 30° and about 85° ; and wherein R is in a
5 range between about $0.23t$ and about $0.5t$, where t is a thickness of the semiconductor wafer.

7. (Original) The wafer of Claim 6, wherein A_2 is greater than about two times A_1 .

8. (Original) The wafer of Claim 6, wherein ϕ_1 is in a range between about 60° and about 75° .

9. (Original) The wafer of Claim 6, wherein t is in a range between about $625\ \mu\text{m}$ and about $825\ \mu\text{m}$.

10. (Currently amended) A semiconductor wafer having an asymmetric edge profile (EP) extending between an inner edge profile (EP_{in}) and an outer edge profile (EP_{out}) as illustrated by FIG. 1, which is incorporated herein, where ϕ_1 is an angle in a range between about 30° and about 85° .

11.-17. (Canceled)

18. (Currently amended) A semiconductor wafer having an asymmetric edge profile (EP2) extending between an inner edge profile ($EP2_{in}$) and an outer edge profile ($EP2_{out}$) as illustrated by FIG. 2, which is incorporated herein; wherein ϕ_1 and ϕ_2 are angles in a range between about 30° and about 85° ; wherein $\phi_1 < \phi_2$; and wherein R is in a range between about $0.23t$ and about $0.5t$, where t is a thickness of the semiconductor wafer.

19. (Original) A semiconductor wafer having an asymmetric edge profile (EP2) extending between an inner edge profile (EP2_{in}) and an outer edge profile (EP2_{out}) as illustrated by FIG. 2, which is incorporated herein;

wherein t is a thickness of the semiconductor wafer, ϕ_1 is an angle in a range between about 30° and about 85°, ϕ_2 is greater than ϕ_1 and less than about 85°, R is a radius of an arc that defines EP2_{in} at a point of intersection with a top surface of the semiconductor wafer, and α is an acute angle that represents an angle of intersection between a bottom surface of the semiconductor wafer and a line that is tangent to the arc at a point on EP2_{out}; and

wherein:

$$A_1 = R(1 - \cos\phi_1);$$

$$A_2 = R(1 - \sin\alpha) + (B_2 - R\cos\alpha)\cot\alpha;$$

$$B_1 = R\sin\phi_1; \text{ and}$$

$$B_2 = t - R\sin\phi_1.$$

20. (Canceled)